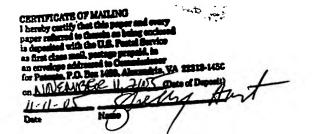
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Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 10/646,460 Filing Date TRANSMITTAL August 22, 2003 First Named Inventor **FORM** Kenneth COLLINS, et al. Art Unit 1763 **Examiner Name** Maureen G. Arancibia Attorney Docket Number 006915 P09 Total Number of Pages in This Submission **ENCLOSURES** (Check all that apply) After Allowance Communication to TC Fee Transmittal Form Drawing(s) Appeal Communication to Board Licensing-related Papers Fee Attached of Appeals and Interferences Appeal Communication to TC Petition (Appeal Notice, Brief, Reply Brief) Amendment/Reply Petition to Convert to a **Proprietary Information** After Final **Provisional Application** Power of Attorney, Revocation Status Letter Affidavits/declaration(s) Change of Correspondence Address Other Enclosure(s) (please Identify **Terminal Disclaimer** below): Extension of Time Request Request for Refund Express Abandonment Request CD, Number of CD(s) Information Disclosure Statement Landscape Table on CD Certified Copy of Priority Remarks Document(s) Reply to Missing Parts/ Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm Name Law Office of Robert M. Wallace Signature Printed name Robert M. Wallace Reg. No. Date 29,119 CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below: Signature Shelly Har Typed or printed name This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to

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Attorney Docket No. 006915 P09 RW Ref. No. APM/001-02-CP1-1-9

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

NOV 1 4 2005

In re Application of

Kenneth COLLINS, et al.

Entitled: PLASMA IMMERSION ION IMPLANTATION SYSTEM INCLUDING AN INDUCTIVELY COUPLED PLASMA SOURCE HAVING LOW DISSOCIATION AND LOW MINIMUM PLASMA VOLTAGE

Serial No.: 10/646,460

Filing Date: August 22, 2003

Group Art Unit: 1763

Examiner: Maureen G.

Arancibia

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(c) PRIOR TO FINAL ACTION AND WITHIN THREE MONTHS OF RECEIVING FOREIGN PATENT OFFICE COMMUNICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication (a copy of which is attached) from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56 and the Manual of Patent Examining Procedures Section 707.5(b). If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each foreign patent document and/or non-patent literature is enclosed. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

Respectfully submitted,

Rohert nuvalen

Robert M. Wallace

Registration No. 29,119 Attorney for Applicants Customer No. 000044843

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Application Number: 10/646,460 INFORMATION Filing Date: August 22, 2003 DISCLOSURE STATEMENT BY APPLICANT First Named Inventor: Kenneth COLLINS, et al. SIPE Group Art Unit: 1763 Maureen G. Arancibia **Examiner Name:** Sheet 1 of 1 006915 P09 Attorney Docket Number: **U. S. PATENT DOCUMENTS** Document Class Subclass Filing Date Publication Date Name of Patentee or Examiner Applicant of Cited Initials Document 05-28-2002 CAN CLEEMPUT ET AL. 204 192.37 04-01-1998 US-6,395,150 B1 118 725 07-02-2002 KIM ET AL. 12-07-2000 US-6.413,321 B1 US 2003/0013260 A1 01-16-2003 **GOSSMAN ET AL.** 438 301 07-16-2001 121.43 04-20-2001 US 2003/0085205 A1 05-08-2003 LAI ET AL. 219 FOREIGN PATENT DOCUMENTS Name of Patentee or Applicant of Translation? Examiner Foreign Patent Publication Country Cited Document (Yes/No/n/a) Initials Document Date EP 1 158 071 A2 28.11.2001 EUROPE APPLIED MATERIALS. N/A INC. 14.02.1995 N/A JP 070455542 **JAPAN** MATSUSHITA ELECTRIC IND CO LTD JP 2000150908 30.05.2000 N/A **JAPAN** SEMICONDUCTOR **ENERGY LAB CO LTD** Examiner NON PATENT LITERATURE DOCUMENTS Initials Hu, C.-K., et al., "A process for improved Al(cu) reactive ion etching", Journal of Vacuum Science and Technology", May 1, 1989, pp. 682-685, Vol. 7, No. 3, American

Examiner's Signature:

Institute of Physics, New York, U.S.

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.